



Docket No.: 50090-306

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PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of

**RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE**

Hiroshi TOBIMATSU, et al.

Serial No.: 09/910,824

: Group Art Unit: 2812

Filed: July 24, 2001

: Examiner: LEE, Hsien Ming

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE HAVING  
PASSIVATION FILM AND BUFFER COATING FILM

**AMENDMENT UNDER 37 CFR §1.116**

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the Office Action dated June 18, 2003, pursuant to the provisions of 37 C.F.R. §1.116.